



JP 2814

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Mitsuhiro Nakamura et al.)	New Docket No:	09794353-0005- ROOM
Serial No:	08/809,463)	Old Attorney Docket No:	P97,0322
Filed:	July 18, 1997)	Group Art Unit No:	2814
Title:	MULTI-LAYERED STRUCTURE FOR FABRICATING AN OHMIC ELECTRODE AND OHMIC ELECTRODE)	Examiner:	P. Cao

CHANGE OF ADDRESS NOTIFICATION

Dear Sir:

Please direct all communications to:

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The undersigned's former firm, Hill & Simpson, P.C., has gone out of business and responsibility for this application has been assigned and assumed by the undersigned.

Respectfully submitted,

SONNENSCHN NATH & ROSENTHAL

August 10, 2001

By:

David R. Metzger
Reg. No. 32,919

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I hereby certify that this document and any being referred to as attached or enclosed is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Assistant Commissioner for Patents, Washington, D.C. 20231 on

Date

Anna M. Franz

August 10, 2001 Anna M. Franz